

Notice of References Cited	Application/Control No. 10/646,615	Applicant(s)/Patent Under Reexamination HENNEN, WILLIAM J.	
	Examiner Taeyoon Kim	Art Unit 1651	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,693,094 B2	02-2004	Pearson et al.	514/188
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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